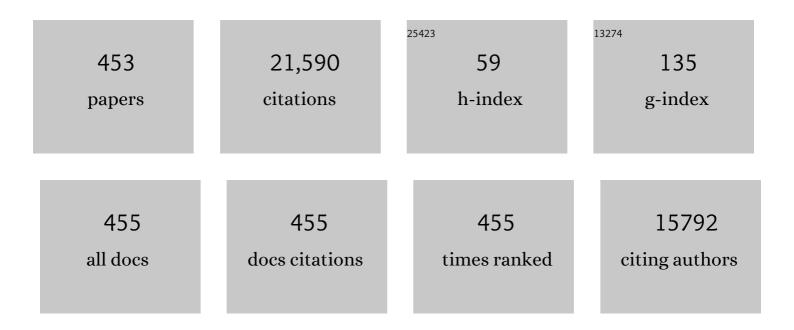
Oliver Ambacher

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/92826/publications.pdf Version: 2024-02-01



#	Article	IF	CITATIONS
1	A Scalable Small-Signal and Noise Model for High-Electron-Mobility Transistors Working Down to Cryogenic Temperatures. IEEE Transactions on Microwave Theory and Techniques, 2022, 70, 1097-1110.	2.9	9
2	Manipulation of the In Situ Nitrogenâ€Vacancy Doping Efficiency in CVDâ€Grown Diamond. Physica Status Solidi (A) Applications and Materials Science, 2022, 219, .	0.8	3
3	On the origin of the turn-on voltage drop of GaN-based current aperture vertical electron transistors. Journal of Applied Physics, 2022, 131, .	1.1	3
4	Effect of V/III ratio and growth pressure on surface and crystal quality of AlN grown on sapphire by metal-organic chemical vapor deposition. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2022, 40, .	0.9	4
5	C-Band Low-Noise Amplifier MMIC with an Average Noise Temperature of 44.5 K and 24.8 mW Power Consumption. , 2022, , .		2
6	Electron accumulation and distribution at interfaces of hexagonal Sc <i>x</i> Al1â^' <i>x</i> N/GaN- and Sc <i>x</i> Al1â^' <i>x</i> N/InN-heterostructures. Journal of Applied Physics, 2022, 131, .	1.1	7
7	Analysis of the Growth of Laterally Aligned SnO ₂ Nanowires by Thermodynamic Considerations and Experiments. Crystal Growth and Design, 2021, 21, 191-199.	1.4	7
8	Growth and Fabrication of Quasivertical Current Aperture Vertical Electron Transistor Structures. Physica Status Solidi (A) Applications and Materials Science, 2021, 218, 2000379.	0.8	9
9	Monolithic Integrated AlGaN/GaN Power Converter Topologies on Highâ€Voltage AlN/GaN Superlattice Buffer. Physica Status Solidi (A) Applications and Materials Science, 2021, 218, 2000404.	0.8	12
10	Metal organic chemical vapour deposition regrown large area GaNâ€onâ€GaN current aperture vertical electron transistors with high current capability. Electronics Letters, 2021, 57, 145-147.	0.5	6
11	Technology of GaN-Based Large Area CAVETs With Co-Integrated HEMTs. IEEE Transactions on Electron Devices, 2021, 68, 5547-5552.	1.6	8
12	Improved AlScN/GaN heterostructures grown by metal-organic chemical vapor deposition. Semiconductor Science and Technology, 2021, 36, 034003.	1.0	34
13	First-principles calculation of electroacoustic properties of wurtzite (Al,Sc)N. Physical Review B, 2021, 103, .	1.1	41
14	Low-Power Differential Input to Single-Ended Output GaN RF-DAC for RF-Signal Generation. IEEE Transactions on Microwave Theory and Techniques, 2021, 69, 1646-1653.	2.9	1
15	A GaN-Based Active Diode Circuit for Low-Loss Rectification. , 2021, , .		1
16	Polarization induced interface and electron sheet charges of pseudomorphic ScAlN/GaN, GaAlN/GaN, InAlN/GaN, and InAlN/InN heterostructures. Journal of Applied Physics, 2021, 129, .	1.1	30
17	Quality Assessment of In Situ Plasmaâ€Etched Diamond Surfaces for Chemical Vapor Deposition Overgrowth. Physica Status Solidi (A) Applications and Materials Science, 2021, 218, 2100035.	0.8	1
18	Investigation of GaN-on-Si and GaN-on-SOI Substrate Capacitances for Discrete and Monolithic		2

Half-Bridges. , 2021, , .

#	Article	IF	CITATIONS
19	On the exceptional temperature stability of ferroelectric Al1-xScxN thin films. Applied Physics Letters, 2021, 118, .	1.5	41
20	Wurtzite ScAlN, InAlN, and GaAlN crystals, a comparison of structural, elastic, dielectric, and piezoelectric properties. Journal of Applied Physics, 2021, 130, .	1.1	40
21	A 50-nm Gate-Length Metamorphic HEMT Technology Optimized for Cryogenic Ultra-Low-Noise Operation. IEEE Transactions on Microwave Theory and Techniques, 2021, 69, 3896-3907.	2.9	17
22	Broadband 400-CHz InGaAs mHEMT Transmitter and Receiver S-MMICs. IEEE Transactions on Terahertz Science and Technology, 2021, 11, 660-675.	2.0	10
23	Atomic scale confirmation of ferroelectric polarization inversion in wurtzite-type AlScN. Journal of Applied Physics, 2021, 129, .	1.1	46
24	Properties of higher-order surface acoustic wave modes in Al1â^'‹i›x‹/i›Sc‹i›x‹/i›N/sapphire structures. Journal of Applied Physics, 2021, 130, .	1.1	8
25	Building Blocks for GaN Power Integration. IEEE Access, 2021, 9, 163122-163137.	2.6	13
26	Metalâ€Organic Chemical Vapor Deposition of Aluminum Scandium Nitride. Physica Status Solidi - Rapid Research Letters, 2020, 14, 1900535.	1.2	54
27	Optimization of Metalâ€Organic Chemical Vapor Deposition Regrown nâ€GaN. Physica Status Solidi (B): Basic Research, 2020, 257, 1900436.	0.7	6
28	Microstructural and optical emission properties of diamond multiply twinned particles. Journal of Applied Physics, 2020, 127, 025303.	1.1	4
29	A 600V p-GaN Gate HEMT with Intrinsic Freewheeling Schottky-Diode in a GaN Power IC with Bootstrapped Driver and Sensors. , 2020, , .		3
30	Noise Performance of Sub-100-nm Metamorphic HEMT Technologies. , 2020, , .		6
31	A Fully-Integrated W-Band I/Q-Down-Conversion MMIC for Use in Radio Astronomical Multi-Pixel Receivers. , 2020, , .		4
32	A GaN-based Current Sense Amplifier for GaN HEMTs with Integrated Current Shunts. , 2020, , .		5
33	Si-Substrate Removal for AlGaN/GaN Devices on PCB Carriers. , 2020, , .		3
34	In-Plane Oriented Stacks of c-AlScN/Mo (110) for BAW Resonators Grown by Magnetron Sputter Epitaxy. , 2020, , .		1
35	A Novel 32-Gb/s 5.6-Vpp Digital-to-Analog Converter in 100 nm GaN Technology for 5G Signal Generation. , 2020, , .		1
36	Metalorganic chemical vapor phase deposition of AlScN/GaN heterostructures. Journal of Applied Physics, 2020, 127, .	1.1	34

#	Article	IF	CITATIONS
37	Large-Area Lateral AlGaN/GaN-on-Si Field-Effect Rectifier With Low Turn-On Voltage. IEEE Electron Device Letters, 2020, 41, 993-996.	2.2	20
38	Enhanced electromechanical coupling in SAW resonators based on sputtered non-polar Al0.77Sc0.23N 112Â ⁻ thin films. Applied Physics Letters, 2020, 116, .	1.5	28
39	Low-Loss Millimeter-Wave SPDT Switch MMICs in a Metamorphic HEMT Technology. IEEE Microwave and Wireless Components Letters, 2020, 30, 197-200.	2.0	17
40	Epitaxial growth of GaN/Ga2O3 and Ga2O3/GaN heterostructures for novel high electron mobility transistors. Journal of Crystal Growth, 2020, 534, 125511.	0.7	35
41	Influence of Different Surface Morphologies on the Performance of High-Voltage, Low-Resistance Diamond Schottky Diodes. IEEE Transactions on Electron Devices, 2020, 67, 2471-2477.	1.6	12
42	Novel Method for Extracting Material Constants of Epitaxial Wurtzite AlScN Films on Sapphire Using Higher Order Surface Acoustic Wave Modes. , 2020, , .		2
43	Experimental determination of the electro-acoustic properties of thin film AlScN using surface acoustic wave resonators. Journal of Applied Physics, 2019, 126, .	1.1	65
44	Optical constants and band gap of wurtzite Al1â°'xScxN/Al2O3 prepared by magnetron sputter epitaxy for scandium concentrations up to x = 0.41. Journal of Applied Physics, 2019, 126, .	1.1	46
45	RF-Noise Model Extraction Procedure for Distributed Multiport Models. , 2019, , .		1
46	Integrated 2-b Riemann Pump RF-DAC in GaN Technology for 5G Base Stations. , 2019, , .		4
47	Integrated Current Sensing in GaN Power ICs. , 2019, , .		11
48	W-Band LNA MMICs Based on a Noise-Optimized 50-nm Gate-Length Metamorphic HEMT Technology. , 2019, , .		17
49	High-Q Anti-Series AlGaN/GaN High Electron-Mobility Varactor. , 2019, , .		3
50	D-Band and G-Band High-Performance GaN Power Amplifier MMICs. IEEE Transactions on Microwave Theory and Techniques, 2019, 67, 5080-5089.	2.9	43
51	Determination of the graphene–graphite ratio of graphene powder by Raman 2D band symmetry analysis. Analytical Methods, 2019, 11, 1224-1228.	1.3	101
52	Large-Signal Modeling of a Scalable High-\${Q}\$ AlGaN/GaN High Electron-Mobility Varactor. IEEE Transactions on Microwave Theory and Techniques, 2019, 67, 922-927.	2.9	4
53	Investigation of growth parameters for ScAIN-barrier HEMT structures by plasma-assisted MBE. Japanese Journal of Applied Physics, 2019, 58, SC1045.	0.8	42
54	Epitaxial growth optimization of AlGaN/GaN high electron mobility transistor structures on 3C-SiC/Si. Journal of Applied Physics, 2019, 125, .	1.1	15

#	Article	IF	CITATIONS
55	AlGaN avalanche Schottky diodes with high Al-content. Japanese Journal of Applied Physics, 2019, 58, SCCC11.	0.8	10
56	A Transmitter System-in-Package at 300 GHz With an Off-Chip Antenna and GaAs-Based MMICs. IEEE Transactions on Terahertz Science and Technology, 2019, 9, 335-344.	2.0	22
57	Highly Scalable Distributed High Electron Mobility Transistor Model. , 2019, , .		3
58	Asymmetrical Substrate-Biasing Effects at up to 350V Operation of Symmetrical Monolithic Normally-Off GaN-on-Si Half-Bridges. , 2019, , .		5
59	A Pseudo-Complementary GaN-Based Gate Driver with Reduced Static Losses. , 2019, , .		3
60	High voltage electrochemical exfoliation of graphite for high-yield graphene production. RSC Advances, 2019, 9, 29305-29311.	1.7	19
61	Experimental determination of Al1-xScxN thin film thermo-electro-acoustic properties up to 140°C by using SAW resonators. , 2019, , .		Ο
62	GCPW GaAs Broadside Couplers at H-Band and Application to Balanced Power Amplifiers. IEEE Transactions on Microwave Theory and Techniques, 2019, 67, 78-85.	2.9	7
63	Temperature Dependence of the Pyroelectric Coefficient of AlScN Thin Films. Physica Status Solidi (A) Applications and Materials Science, 2018, 215, 1700831.	0.8	24
64	Broadband High-Power W-Band Amplifier MMICs Based on Stacked-HEMT Unit Cells. IEEE Transactions on Microwave Theory and Techniques, 2018, 66, 1312-1318.	2.9	29
65	Avalanche multiplication in AlGaN-based heterostructures for the ultraviolet spectral range. Applied Physics Letters, 2018, 112, .	1.5	17
66	Highly Isolating and Broadband Single-Pole Double-Throw Switches for Millimeter-Wave Applications Up to 330 GHz. IEEE Transactions on Microwave Theory and Techniques, 2018, 66, 1998-2009.	2.9	29
67	Graphene as an active virtually massless top electrode for RF solidly mounted bulk acoustic wave (SMR-BAW) resonators. Nanotechnology, 2018, 29, 105302.	1.3	12
68	Analysis and Development of Submillimeter-Wave Stacked-FET Power Amplifier MMICs in 35-nm mHEMT Technology. IEEE Transactions on Terahertz Science and Technology, 2018, 8, 357-364.	2.0	14
69	W-band SPDT switches in planar and tri-gate 100-nm gate-length GaN-HEMT technology. , 2018, , .		20
70	Voltage- and Temperature-Dependent Degradation of AIN/GaN High Electron Mobility Transistors. , 2018, , .		3
71	Multi-Stage Cascode in High-Voltage AlGaN/GaN-on-Si Technology. , 2018, , .		6
72	Full W-Band GaN Power Amplifier MMICs Using a Novel Type of Broadband Radial Stub. IEEE Transactions on Microwave Theory and Techniques, 2018, 66, 5664-5675.	2.9	19

#	Article	IF	CITATIONS
73	Determination of Elastic and Piezoelectric Properties of Al _{0.84} Sc _{0.16} N Thin Films. , 2018, , .		2
74	Instabilities by Parasitic Substrate-Loop of GaN-on-Si HEMTs in Half-Bridges. , 2018, , .		1
75	Riemann-Pump based RF-Power DACs in GaN Technology for 5G Base Stations. , 2018, , .		5
76	A \$C\$ -Band Broadband Balanced Power Amplifier Module Based on Cascode mHEMTs. IEEE Microwave and Wireless Components Letters, 2018, 28, 924-926.	2.0	7
77	Investigations of Active Antenna Doherty Power Amplifier Modules Under Beam-Steering Mismatch. IEEE Microwave and Wireless Components Letters, 2018, 28, 930-932.	2.0	10
78	Monolithically integrated power circuits in highâ€voltage GaNâ€onâ€Si heterojunction technology. IET Power Electronics, 2018, 11, 681-688.	1.5	35
79	Transfer of AlGaN/GaN RF-devices onto diamond substrates via van der Waals bonding. International Journal of Microwave and Wireless Technologies, 2018, 10, 666-673.	1.5	20
80	Elastic modulus and coefficient of thermal expansion of piezoelectric Al _{1â^'x} Sc _x N (up to x = 0.41) thin films. APL Materials, 2018, 6, 076105.	2.2	71
81	Temperature Cross-Sensitivity of AlN-Based Flexural Plate Wave Sensors. IEEE Sensors Journal, 2018, 18, 7810-7818.	2.4	4
82	A 300 GHz microstrip multilayered antenna on quartz substrate. , 2018, , .		7
83	\${W}\$ -Band Time-Domain Multiplexing FMCW MIMO Radar for Far-Field 3-D Imaging. IEEE Transactions on Microwave Theory and Techniques, 2017, 65, 3474-3484.	2.9	105
84	Microstructure and mechanical properties of stress-tailored piezoelectric AlN thin films for electro-acoustic devices. Applied Surface Science, 2017, 407, 307-314.	3.1	34
85	Nanodiamond resonators fabricated on 8″ Si substrates using adhesive wafer bonding. Journal of Micromechanics and Microengineering, 2017, 27, 065011.	1.5	2
86	Reliability Analysis of LPCVD SiN Gate Dielectric for AlGaN/GaN MIS-HEMTs. IEEE Transactions on Electron Devices, 2017, 64, 2298-2305.	1.6	28
87	Development of a Silicon-Only Capacitive Dew Point Sensor. IEEE Sensors Journal, 2017, 17, 7223-7230.	2.4	5
88	AlN/GaN HEMTs grown by MBE and MOCVD: Impact of Al distribution. Physica Status Solidi (B): Basic Research, 2017, 254, 1600715.	0.7	23
89	Design, Realization, and Evaluation of a Riemann Pump in GaN Technology. IEEE Microwave and Wireless Components Letters, 2017, 27, 672-674.	2.0	6
90	Substrate biasing effects in a high-voltage, monolithically-integrated half-bridge GaN-Chip. , 2017, , .		25

#	Article	IF	CITATIONS
91	Effect of substrate termination on switching loss and switching time using 600 V GaN-on-Si HEMTs with integrated gate driver in half-bridges. , 2017, , .		13
92	Operation of PCB-embedded, high-voltage multilevel-converter GaN-IC. , 2017, , .		11
93	Wettability Investigations and Wet Transfer Enhancement of Large-Area CVD-Graphene on Aluminum Nitride. Nanomaterials, 2017, 7, 226.	1.9	7
94	Electrostatic Self-Assembly of Diamond Nanoparticles onto Al- and N-Polar Sputtered Aluminum Nitride Surfaces. Nanomaterials, 2016, 6, 217.	1.9	10
95	Quasi-Bessel beams from asymmetric and astigmatic illumination sources. Optics Express, 2016, 24, 17433.	1.7	9
96	Piezoelectric AlN Films for FPW Sensors with Improved Device Performance. Procedia Engineering, 2016, 168, 1040-1043.	1.2	3
97	Compact W-band receiver module on hybrid liquid crystal polymer board. , 2016, , .		4
98	Single-input GaN gate driver based on depletion-mode logic integrated with a 600 V GaN-on-Si power transistor. , 2016, , .		10
99	Soft-switching 3 MHz converter based on monolithically integrated half-bridge GaN-chip. , 2016, , .		18
100	Enhanced actuation of nanocrystalline diamond microelectromechanical disk resonators with AlN layers. Applied Physics Letters, 2016, 108, .	1.5	9
101	Analysis and optimization of sputter deposited AlN-layers for flexural plate wave devices. Journal of Vacuum Science and Technology B:Nanotechnology and Microelectronics, 2016, 34, .	0.6	18
102	Piezo-force and Vibration Analysis of ZnO Nanowire Arrays for Sensor Application. Procedia Engineering, 2016, 168, 1192-1195.	1.2	9
103	Study of a silicon parallel plate capacitor as a dew point sensor. , 2016, , .		4
104	Measurement setup for the analysis of broadband frequency-modulated signals. , 2016, , .		0
105	Material characterization using a compact W-band ellipsometer. , 2016, , .		1
106	A W-band wireless communication transmitter utilizing a stacked-FET oscillator for high output power performance. , 2016, , .		3
107	An investigation of millimeter wave switches based on shunt transistors including SPDT SWITCH MMICs up to 300 GHz. , 2016, , .		8
108	Post drain-stress behavior of AlGaN/GaN-on-Si MIS-HEMTs. Solid-State Electronics, 2016, 125, 125-132.	0.8	0

#	Article	IF	CITATIONS
109	Small signal modelling approach for submillimeter wave III–V HEMTs with analysation and optimization possibilities. , 2016, , .		13
110	RF Performance of Trigate GaN HEMTs. IEEE Transactions on Electron Devices, 2016, 63, 4255-4261.	1.6	18
111	Stability Investigation of Large Gate-Width Metamorphic High Electron-Mobility Transistors at Cryogenic Temperature. IEEE Transactions on Microwave Theory and Techniques, 2016, 64, 3139-3150.	2.9	16
112	Spectroscopic Measurement of Material Properties Using an Improved Millimeter-Wave Ellipsometer Based on Metallic Substrates. IEEE Transactions on Instrumentation and Measurement, 2016, 65, 2551-2559.	2.4	5
113	Low noise amplifiers for MetOp-SG. , 2016, , .		5
114	Complex interaction of passive multiport structures and their description by separate discrete models. Electronics Letters, 2016, 52, 52-54.	0.5	1
115	Linear temperature sensors in high-voltage GaN-HEMT power devices. , 2016, , .		9
116	The role of surface electron accumulation and bulk doping for gas-sensing explored with single-crystalline In2O3 thin films. Sensors and Actuators B: Chemical, 2016, 236, 909-916.	4.0	41
117	Prospects and Limitations of Stacked-FET Approaches for Enhanced Output Power in Voltage-Controlled Oscillators. IEEE Transactions on Microwave Theory and Techniques, 2016, 64, 836-846.	2.9	13
118	Pinhole-free ultra-thin nanocrystalline diamond film growth via electrostatic self-assembly seeding with increased salt concentration of nanodiamond colloids. Diamond and Related Materials, 2016, 63, 103-107.	1.8	16
119	Admittance–voltage profiling of AlxGa1â"xN/GaN heterostructures: Frequency dependence of capacitance and conductance. Journal of Applied Physics, 2015, 118, .	1.1	4
120	Large area InN terahertz emitters based on the lateral photo-Dember effect. Applied Physics Letters, 2015, 107, .	1.5	7
121	Characterization of quasi-optical focusing systems at W-band frequencies. , 2015, , .		3
122	Dynamic Detection of Target-DNA with AlGaN/GaN High Electron Mobility Transistors. Procedia Engineering, 2015, 120, 908-911.	1.2	3
123	Monolithic integrated quasi-normally-off gate driver and 600 V GaN-on-Si HEMT. , 2015, , .		20
124	Impact of Metallization Layer Structure on the Performance of G-Band Branch-Line Couplers. IEEE Microwave and Wireless Components Letters, 2015, 25, 793-795.	2.0	3
125	Impedance Characterization of DNA-functionalization Layers on AlGaN/GaN High Electron Mobility Transistors. Procedia Engineering, 2015, 120, 912-915.	1.2	3
126	A compact W-band LFMCW radar module with high accuracy and integrated signal processing. , 2015, , .		17

#	Article	lF	CITATIONS
127	Monolithic three-stage 6–18GHz high power amplifier with distributed interstage in GaN technology. , 2015, , .		7
128	Detection of different target-DNA concentrations with highly sensitive AlGaN/GaN high electron mobility transistors. Sensors and Actuators B: Chemical, 2015, 210, 633-639.	4.0	27
129	Threshold Voltage Engineering in GaN-Based HFETs: A Systematic Study With the Threshold Voltage Reaching More Than 2 V. IEEE Transactions on Electron Devices, 2015, 62, 538-545.	1.6	23
130	High-voltage stress time-dependent dispersion effects in AlGaN/GaN HEMTs. , 2015, , .		6
131	Integrated reverse-diodes for GaN-HEMT structures. , 2015, , .		26
132	Quasi-normally-off GaN gate driver for high slew-rate d-mode GaN-on-Si HEMTs. , 2015, , .		6
133	Charge balancing in GaN-based 2-D electron gas devices employing an additional 2-D hole gas and its influence on dynamic behaviour of GaN-based heterostructure field effect transistors. Journal of Applied Physics, 2015, 117, .	1.1	21
134	Appropriate Salt Concentration of Nanodiamond Colloids for Electrostatic Self-Assembly Seeding of Monosized Individual Diamond Nanoparticles on Silicon Dioxide Surfaces. Langmuir, 2015, 31, 5319-5325.	1.6	50
135	High-Efficiency, High-Temperature Continuous Class-E Sub-Waveform Solution AlGaN/GaN Power Amplifier. IEEE Microwave and Wireless Components Letters, 2015, 25, 526-528.	2.0	7
136	Normally-Off AlGaN/GaN/AlGaN Double Heterostructure FETs With a Thick Undoped GaN Gate Layer. IEEE Electron Device Letters, 2015, 36, 905-907.	2.2	16
137	Vertical Buffer Leakage and Temperature Effects on the Breakdown Performance of GaN/AlGaN HEMTs on Si Substrate. ECS Transactions, 2015, 69, 65-70.	0.3	5
138	A 183 GHz Metamorphic HEMT Low-Noise Amplifier With 3.5 dB Noise Figure. IEEE Microwave and Wireless Components Letters, 2015, 25, 618-620.	2.0	31
139	On the Accurate Measurement and Calibration of S-Parameters for Millimeter Wavelengths and Beyond. IEEE Transactions on Microwave Theory and Techniques, 2015, 63, 2335-2342.	2.9	30
140	Monolithically-Integrated Mulitlevel Inverter on Lateral GaN-on-Si Technology for High-Voltage Applications. , 2015, , .		6
141	Electrochemical generation of hydrogenated graphene flakes. Carbon, 2015, 83, 128-135.	5.4	49
142	Investigation of dielectric properties of multilayer structures consisting of homogeneous plastics and liquid solutions at 75–110 GHz. Journal of Sensors and Sensor Systems, 2015, 4, 125-131.	0.6	2
143	Nano-diamond based spheres for radio frequency electromechanical resonators. Journal of Micromechanics and Microengineering, 2014, 24, 045015.	1.5	3
144	Realization of a 30-W highly efficient and linear reconfigurable dual-band power amplifier using the continuous mode approach. International Journal of Microwave and Wireless Technologies, 2014, 6, 115-128.	1.5	7

#	Article	IF	CITATIONS
145	243ÂGHz low-noise amplifier MMICs and modules based on metamorphic HEMT technology. International Journal of Microwave and Wireless Technologies, 2014, 6, 215-223.	1.5	15
146	Reliability of GaN HEMTs with a 100 nm gate length under DC-stress tests. , 2014, , .		4
147	Planar Zero Bias Schottky Diodes on an InGaAs Metamorphic HEMT MMIC Process. IEEE Microwave and Wireless Components Letters, 2014, 24, 860-862.	2.0	6
148	Influence of surface states on the voltage robustness of AlGaN/GaN HFET power devices. Microelectronics Reliability, 2014, 54, 2656-2661.	0.9	9
149	Combining external cavity quantum cascade lasers and MOEMS technology: An approach for miniaturization and fast wavelength scanning. , 2014, , .		0
150	Elastic properties of ultrathin diamond/AlN membranes. Thin Solid Films, 2014, 558, 267-271.	0.8	10
151	Excitons and excitonâ€phonon coupling in the optical response of GaN. Physica Status Solidi C: Current Topics in Solid State Physics, 2014, 11, 297-301.	0.8	4
152	A scalable compact small-signal mHEMT model accounting for distributed effects in sub-millimeter wave and terahertz applications. , 2014, , .		6
153	Improved AlGaN p-i-n Photodetectors for Monitoring of Ultraviolet Radiation. IEEE Journal of Selected Topics in Quantum Electronics, 2014, 20, 166-172.	1.9	22
154	Processing of Nanoscale Gaps for Boron-doped Nanocrystalline Diamond Based MEMS. Procedia Engineering, 2014, 87, 903-906.	1.2	2
155	Functional Nanowires: Synthesis, Characterization and Applications. Physica Status Solidi C: Current Topics in Solid State Physics, 2014, 11, 313-314.	0.8	0
156	Electroluminescence Investigation of the Lateral Field Distribution in AlGaN/GaN HEMTs for Power Applications. Acta Physica Polonica A, 2014, 125, 982-985.	0.2	3
157	CIP (cleaning-in-place) stability of AlGaN/GaN pH sensors. Journal of Biotechnology, 2013, 163, 354-361.	1.9	10
158	Piezoelectric actuated micro-resonators based on the growth of diamond on aluminum nitride thin films. Nanotechnology, 2013, 24, 025601.	1.3	46
159	High-Gain Millimeter-Wave AlGaN/GaN Transistors. IEEE Transactions on Electron Devices, 2013, 60, 3112-3118.	1.6	16
160	Enhanced mechanical performance of AlN/nanodiamond micro-resonators. Journal of Micromechanics and Microengineering, 2013, 23, 125017.	1.5	18
161	Wireless sub-THz communication system with high data rate. Nature Photonics, 2013, 7, 977-981.	15.6	1,137
162	Sub-10 nanometer uncooled platinum bolometers via plasma enhanced atomic layer deposition. , 2013, ,		9

Oliver Ambacher

#	Article	IF	CITATIONS
163	Novel semi-reactively-matched multistage broadband power amplifier architecture for monolithic ICs in GaN technology. , 2013, , .		8
164	Transparent diamond electrodes for tunable micro-optical devices. Diamond and Related Materials, 2013, 38, 101-103.	1.8	10
165	Benchmarking of Large-Area GaN-on-Si HFET Power Devices for Highly-Efficient, Fast-Switching Converter Applications. , 2013, , .		9
166	GaNâ€based high voltage transistors for efficient power switching. Physica Status Solidi C: Current Topics in Solid State Physics, 2013, 10, 831-834.	0.8	33
167	Thermal Functionalization of GaN Surfaces with 1-Alkenes. Langmuir, 2013, 29, 6296-6301.	1.6	11
168	Piezoelectrically actuated diamond cantilevers for high-frequency applications. Diamond and Related Materials, 2013, 38, 69-72.	1.8	0
169	Corrugated piezoelectric membranes for energy harvesting from aperiodic vibrations. Sensors and Actuators A: Physical, 2013, 195, 32-37.	2.0	7
170	A 67 GHz GaN Voltage-Controlled Oscillator MMIC With High Output Power. IEEE Microwave and Wireless Components Letters, 2013, 23, 374-376.	2.0	16
171	Seebeck ozone sensors. , 2013, , .		1
172	Dynamics of thermalization in GaInN/GaN quantum wells grown on ammonothermal GaN. Journal of Applied Physics, 2013, 114, .	1.1	14
173	A 243 GHz LNA Module Based on mHEMT MMICs With Integrated Waveguide Transitions. IEEE Microwave and Wireless Components Letters, 2013, 23, 486-488.	2.0	22
174	Mechanical and electrical properties of plasma and thermal atomic layer deposited Al2O3 films on GaAs and Si. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2013, 31, .	0.9	16
175	Crystallographic Texture of Submicron Thin Aluminum Nitride Films on Molybdenum Electrode for Suspended Micro and Nanosystems. ECS Journal of Solid State Science and Technology, 2013, 2, P180-P184.	0.9	2
176	W-band active loads and switching front-end MMICs for radiometer calibration. International Journal of Microwave and Wireless Technologies, 2013, 5, 293-299.	1.5	1
177	Microscopic Degradation Analysis of RF-Stressed AlGaN/GaN HEMTs. Materials Science Forum, 2012, 725, 79-82.	0.3	2
178	Reverse bias stress test of GaN HEMTs for high-voltage switching applications. , 2012, , .		2
179	Broadband MMIC tuners dedicated to noise parameter measurements at cryogenic temperatures. , 2012, , .		0
180	Electrostatically coupled vibration modes in unimorph complementary microcantilevers. Applied Physics Letters, 2012, 100, 124104.	1.5	8

#	Article	IF	CITATIONS
181	220 GHz wireless data transmission experiments up to 30 Gbit/s. , 2012, , .		15
182	Active load modules for W-band radiometer calibration. , 2012, , .		7
183	Wireless multi-gigabit data transmission using active MMIC components at 220ÂGHz. International Journal of Microwave and Wireless Technologies, 2012, 4, 291-298.	1.5	0
184	A U-band broadband power amplifier MMIC in 100 nm AlGaN/GaN HEMT technology. , 2012, , .		2
185	A W-Band MMIC Radar System for Remote Detection of Vital Signs. Journal of Infrared, Millimeter, and Terahertz Waves, 2012, 33, 1250-1267.	1.2	13
186	A Noise Source Module for In-Situ Noise Figure Measurements From DC to 50 GHz at Cryogenic Temperatures. IEEE Microwave and Wireless Components Letters, 2012, 22, 657-659.	2.0	2
187	Fractal structures for low-resistance large area AlGaN/GaN power transistors. , 2012, , .		5
188	AlGaN/GaN power amplifiers for ISM applications. Solid-State Electronics, 2012, 74, 108-113.	0.8	4
189	Threading dislocation propagation in AlGaN/GaN based HEMT structures grown on Si (111) by plasma assisted molecular beam epitaxy. Journal of Crystal Growth, 2012, 357, 35-41.	0.7	18
190	GaN-based millimeter-wave monolithic integrated circuits. , 2012, , .		0
191	450 GHz amplifier MMIC in 50 nm metamorphic HEMT technology. , 2012, , .		30
192	Radiative inter-valley transitions as a dominant emission mechanism in AlGaN/GaN high electron mobility transistors. Semiconductor Science and Technology, 2012, 27, 125003.	1.0	20
193	Hafnium oxide passivation of InGaAs/InP heterostructure bipolar transistors by electron beam evaporation. Physica Status Solidi C: Current Topics in Solid State Physics, 2012, 9, 381-384.	0.8	3
194	Evaluation of AlN material properties through vibration analysis of thin membranes. Physica Status Solidi C: Current Topics in Solid State Physics, 2012, 9, 403-406.	0.8	6
195	GaN-based high-frequency devices and circuits: A Fraunhofer perspective. Physica Status Solidi (A) Applications and Materials Science, 2012, 209, 491-496.	0.8	9
196	Static and dynamic characterization of AlN and nanocrystalline diamond membranes. Physica Status Solidi (A) Applications and Materials Science, 2012, 209, 1835-1842.	0.8	13
197	Influence of plasma treatments on the properties of GaN/AlGaN/GaN HEMT structures. Physica Status Solidi C: Current Topics in Solid State Physics, 2012, 9, 1096-1098.	0.8	8
198	Plasma affected 2DEG properties on GaN/AlGaN/GaN HEMTs. Physica Status Solidi C: Current Topics in Solid State Physics, 2012, 9, 938-941.	0.8	2

#	Article	IF	CITATIONS
199	Photon stimulated ozone sensor based on indium oxide nanoparticles II: Ozone monitoring in humidity and water environments. Sensors and Actuators B: Chemical, 2012, 164, 37-42.	4.0	15
200	Reliability and degradation mechanism of 0.25 ŵm AlGaN/GaN HEMTs under RF stress conditions. , 2011, , .		5
201	Sub-MHz-Linewidth 200-mW Actively Stabilized 2.3-μm Semiconductor Disk Laser. IEEE Photonics Technology Letters, 2011, 23, 1538-1540.	1.3	12
202	Improved Structural and Chemical Properties of Nearly Lattice-Matched Ternary and Quaternary Barriers for GaN-Based HEMTs. Crystal Growth and Design, 2011, 11, 2588-2591.	1.4	14
203	Dual-Gate GaN MMICs for MM-Wave Operation. IEEE Microwave and Wireless Components Letters, 2011, 21, 95-97.	2.0	20
204	2 μm semiconductor disk laser with a heterodyne linewidth below 10 kHz. Optics Letters, 2011, 36, 3587.	1.7	20
205	Metamorphic HEMT MMICs and Modules Operating Between 300 and 500 GHz. IEEE Journal of Solid-State Circuits, 2011, 46, 2193-2202.	3.5	89
206	MMIC based wireless data transmission of a 12.5 Gbit/s signal using a 220 GHz carrier. , 2011, , .		4
207	Microstructural Characterization of Closely-Lattice-Matched AlIn(Ga)N Alloys for High Electron Mobility Transistors. Microscopy and Microanalysis, 2011, 17, 1354-1355.	0.2	0
208	GaN HFET MMICs with integrated Schottky-diode for highly efficient digital switch-mode power amplifiers at 2ÂGHz. International Journal of Microwave and Wireless Technologies, 2011, 3, 319-327.	1.5	1
209	DNAâ€sensor based on AlGaN/GaN high electron mobility transistor. Physica Status Solidi (A) Applications and Materials Science, 2011, 208, 1626-1629.	0.8	29
210	Micro†and nanoâ€electromechanical resonators based on SiC and group IIIâ€nitrides for sensor applications. Physica Status Solidi (A) Applications and Materials Science, 2011, 208, 357-376.	0.8	43
211	Electron and hole accumulation in InN/InGaN heterostructures. Physica Status Solidi C: Current Topics in Solid State Physics, 2011, 8, 485-487.	0.8	2
212	Dynamic characterization of thin aluminum nitride microstructures. Physica Status Solidi C: Current Topics in Solid State Physics, 2011, 8, 479-481.	0.8	3
213	Development of a high transconductance GaN MMIC technology for millimeter wave applications. Physica Status Solidi C: Current Topics in Solid State Physics, 2011, 8, 297-299.	0.8	18
214	Growth and characterization of InAlN layers nearly latticeâ€matched to GaN. Physica Status Solidi C: Current Topics in Solid State Physics, 2011, 8, 2500-2502.	0.8	4
215	Critical factors influencing the voltage robustness of AlGaN/GaN HEMTs. Microelectronics Reliability, 2011, 51, 224-228.	0.9	8
216	Photon stimulated sensor based on indium oxide nanoparticles I: Wide-concentration-range ozone monitoring in air. Sensors and Actuators B: Chemical, 2011, 152, 235-240.	4.0	58

#	Article	IF	CITATIONS
217	InP-based heterojunction bipolar transistors with InGaAs/GaAs strained-layer-superlattice. Applied Physics Letters, 2011, 98, 043503.	1.5	5
218	High-performance 60ÂGHz MMICs for wireless digital communication in 100Ânm mHEMT technology. International Journal of Microwave and Wireless Technologies, 2011, 3, 107-113.	1.5	4
219	Atomic Layer Deposition of Aluminum Oxide for Surface Passivation of InGaAsâ •InP Heterojunction Bipolar Transistors. Journal of the Electrochemical Society, 2011, 158, H1279.	1.3	6
220	Design and model studies for solid-state power amplification at 210ÂGHz. International Journal of Microwave and Wireless Technologies, 2011, 3, 339-346.	1.5	1
221	AlGaN/GaN epitaxy and technology. International Journal of Microwave and Wireless Technologies, 2010, 2, 3-11.	1.5	26
222	Structural and compositional homogeneity of InAlN epitaxial layers nearly lattice-matched to GaN. Acta Materialia, 2010, 58, 4120-4125.	3.8	26
223	Investigation of Leakage Current of AlGaN/GaN HEMTs Under Pinch-Off Condition by Electroluminescence Microscopy. Journal of Electronic Materials, 2010, 39, 756-760.	1.0	19
224	Elastic properties of nanowires. Physica Status Solidi (B): Basic Research, 2010, 247, 2557-2570.	0.7	33
225	Nearâ€UV LEDs for integrated InOâ€based ozone sensors. Physica Status Solidi C: Current Topics in Solid State Physics, 2010, 7, 2177-2179.	0.8	2
226	Development of rugged 2 GHz power bars delivering more than 100 W and 60% power added efficiency. Physica Status Solidi C: Current Topics in Solid State Physics, 2010, 7, 2398-2403.	0.8	6
227	AlGaN/GaN Based Heterostructures for MEMS and NEMS Applications. Solid State Phenomena, 2010, 159, 27-38.	0.3	0
228	Compositional variation of nearly lattice-matched InAlGaN alloys for high electron mobility transistors. Applied Physics Letters, 2010, 96, .	1.5	31
229	Impact of Al content on transport properties of two-dimensional electron gas in GaN/AlxGa1â^'xN/GaN heterostructures. Applied Physics Letters, 2010, 97, .	1.5	17
230	Design and realization of GaN RF-devices and circuits from 1 to 30ÂGHz. International Journal of Microwave and Wireless Technologies, 2010, 2, 115-120.	1.5	5
231	Diamondâ^•AlN Thin Films for Optical Applications. , 2010, , .		0
232	GaN-Based Submicrometer HEMTs With Lattice-Matched InAlGaN Barrier Grown by MBE. IEEE Electron Device Letters, 2010, 31, 671-673.	2.2	48
233	A novel functionalization of AlGaN/GaN-pH-Sensors for DNA-sensors. Materials Research Society Symposia Proceedings, 2009, 1202, 150.	0.1	1
234	InP DHBT-based 1:2 DEMUX IC operating at up to 120â€Gbit/s. Electronics Letters, 2009, 45, 1340.	0.5	2

#	Article	IF	CITATIONS
235	GaN HEMT and MMIC development at Fraunhofer IAF: performance and reliability. Physica Status Solidi (A) Applications and Materials Science, 2009, 206, 1215-1220.	0.8	27
236	Development of AlGaN/GaN HEMTs with efficiencies above 60% up to 100 V for next generation mobile communication 100 W power bars. Physica Status Solidi C: Current Topics in Solid State Physics, 2009, 6, 1369-1372.	0.8	1
237	Advanced mHEMT MMICs for 220 GHz highâ€resolution imaging systems. Physica Status Solidi C: Current Topics in Solid State Physics, 2009, 6, 1390-1393.	0.8	2
238	-band ESR studies of structural anisotropy in P3HT and P3HT/PCBM blend polymer solid films: Paramagnetic defects after continuous wave Xe-lamp photolysis. Solid State Communications, 2009, 149, 893-897.	0.9	15
239	Determination of the composition of InxGa1â^'xN from strain measurements. Acta Materialia, 2009, 57, 5681-5692.	3.8	65
240	Observation of Fermi-edge excitons and exciton-phonon complexes in the optical response of heavily doped <mml:math <br="" xmlns:mml="http://www.w3.org/1998/Math/MathML">display="inline"><mml:mi>n</mml:mi></mml:math> -type wurtzite GaN. Physical Review B, 2009, 79, .	1.1	22
241	NOx sensing properties of In2O3 thin films grown by MOCVD. Sensors and Actuators B: Chemical, 2008, 129, 467-472.	4.0	53
242	Integration of Thinâ€Filmâ€Fractureâ€Based Nanowires into Microchip Fabrication. Small, 2008, 4, 2214-2221.	5.2	24
243	AlGaN/GaNâ€based MEMS with twoâ€dimensional electron gas for novel sensor applications. Physica Status Solidi C: Current Topics in Solid State Physics, 2008, 5, 1914-1916.	0.8	17
244	Dynamical optical investigation of polymer/fullerene composite solar cells. Physica Status Solidi (B): Basic Research, 2008, 245, 714-719.	0.7	11
245	TRESR study of the photo-induced electron transfer in P3DDT/maleic anhydride blend in THF solution under UV flash photolysis. Journal of Molecular Liquids, 2008, 141, 54-61.	2.3	1
246	NOx sensing properties of In2O3 nanoparticles prepared by metal organic chemical vapor deposition. Sensors and Actuators B: Chemical, 2008, 130, 589-593.	4.0	60
247	Highly efficient THz emission from differently grown InN at 800nm and 1060nm excitation. Optics Communications, 2008, 281, 3776-3780.	1.0	19
248	Electric field distribution in GaNâ^•AlGaNâ^•GaN heterostructures with two-dimensional electron and hole gas. Applied Physics Letters, 2008, 92, 013510.	1.5	15
249	Phase Stabilization and Phonon Properties of Single Crystalline Rhombohedral Indium Oxide. Crystal Growth and Design, 2008, 8, 1257-1260.	1.4	118
250	Piezoelectric actuation of (GaN/)AlGaN/GaN heterostructures. Journal of Applied Physics, 2008, 104, 084516.	1.1	30
251	Metamorphic HEMT MMICs and Modules for Use in a High-Bandwidth 210 GHz Radar. IEEE Journal of Solid-State Circuits, 2008, 43, 2194-2205.	3.5	56
252	Reliability and degradation mechanism of AlGaN/GaN HEMTs for next generation mobile communication systems. , 2008, , .		3

#	Article	IF	CITATIONS
253	Two-dimensional electron gas based actuation of piezoelectric AlGaN/GaN microelectromechanical resonators. Applied Physics Letters, 2008, 93, .	1.5	36
254	Anisotropy of the momentum matrix element, dichroism, and conduction-band dispersion relation of wurtzite semiconductors. Physical Review B, 2008, 78, .	1.1	43
255	Electronic and photoconductive properties of ultrathin InGaN photodetectors. Journal of Applied Physics, 2008, 103, 073715.	1.1	10
256	Formation of Si clusters in AlGaN: A study of local structure. Applied Physics Letters, 2007, 90, 181129.	1.5	9
257	Reduced surface electron accumulation at InN films by ozone induced oxidation. Applied Physics Letters, 2007, 90, 152106.	1.5	36
258	Structural studies of single crystalline In2O3 films epitaxially grown on InN(0001). Applied Physics Letters, 2007, 90, 221902.	1.5	27
259	Effect of surface oxidation on electron transport in InN thin films. Journal of Applied Physics, 2007, 101, 123705.	1.1	19
260	Suspended nanowire web. Applied Physics Letters, 2007, 90, 101504.	1.5	12
261	Evidence of electron accumulation at nonpolar surfaces of InN nanocolumns. Applied Physics Letters, 2007, 90, 262110.	1.5	81
262	TEM investigation of sputtered and epitaxial grown indium oxide layers for ozone sensors. Microscopy and Microanalysis, 2007, 13, 406-407.	0.2	0
263	Integration of In2O3 nanoparticle based ozone sensors with GaInNâ^•GaN light emitting diodes. Applied Physics Letters, 2007, 91, .	1.5	73
264	Strain- and pressure-dependent RF response of microelectromechanical resonators for sensing applications. Journal of Micromechanics and Microengineering, 2007, 17, 2016-2023.	1.5	35
265	Stability of GaN films under intense MeV He ion irradiation. Diamond and Related Materials, 2007, 16, 1437-1440.	1.8	3
266	Group III nitride and SiC based MEMS and NEMS: materials properties, technology and applications. Journal Physics D: Applied Physics, 2007, 40, S19.	1.3	329
267	Using defined structures on very thin foils for characterizing AFM tips. Ultramicroscopy, 2007, 107, 1086-1090.	0.8	8
268	Transparent conducting indium oxide thin films grown by low-temperature metal organic chemical vapor deposition. Thin Solid Films, 2007, 515, 2921-2925.	0.8	32
269	Markers prepared by focus ion beam technique for nanopositioning procedures. Microelectronic Engineering, 2007, 84, 524-527.	1.1	5
270	Nanowire-based electromechanical biomimetic sensor. Physica E: Low-Dimensional Systems and Nanostructures, 2007, 37, 208-211.	1.3	16

#	Article	IF	CITATIONS
271	Electrical performance of gallium nitride nanocolumns. Physica E: Low-Dimensional Systems and Nanostructures, 2007, 37, 200-203.	1.3	22
272	Growth of silicon nanowires on UV-structurable glass using self-organized nucleation centres. Physica E: Low-Dimensional Systems and Nanostructures, 2007, 38, 40-43.	1.3	3
273	Reactively sputtered InxVyOz films for detection of NOx, D2, and O2. Sensors and Actuators B: Chemical, 2007, 123, 779-783.	4.0	5
274	AlGaN/GaN biosensor—effect of device processing steps on the surface properties and biocompatibility. Sensors and Actuators B: Chemical, 2007, 123, 740-748.	4.0	67
275	Effect of island coalescence on structural and electrical properties of InN thin films. Journal of Crystal Growth, 2007, 300, 50-56.	0.7	3
276	Morphology and surface electronic structure of MBE grown InN. Journal of Crystal Growth, 2007, 306, 6-11.	0.7	41
277	Fully unstrained GaN on sacrificial AlN layers by nano-heteroepitaxy. Physica Status Solidi C: Current Topics in Solid State Physics, 2007, 4, 2248-2251.	0.8	4
278	High efficient terahertz emission from InN surfaces. Physica Status Solidi (B): Basic Research, 2007, 244, 1829-1833.	0.7	19
279	Degradation processes in the cellulose/N-methylmorpholine-N-oxide system studied by HPLC and ESR. Radical formation/recombination kinetics under UV photolysis at 77ÅK. Cellulose, 2007, 14, 457-468.	2.4	9
280	SiC-based FET for detection of NOx and O2 using InSnOx as a gate material. Sensors and Actuators B: Chemical, 2007, 122, 182-186.	4.0	10
281	Tuning of electrical and structural properties of indium oxide films grown by metal organic chemical vapor deposition. Thin Solid Films, 2007, 515, 6611-6614.	0.8	33
282	Analysis of nanocrystalline films on rough substrates. Ultramicroscopy, 2007, 107, 989-994.	0.8	5
283	Preparation of defined structures on very thin foils for characterization of AFM probes. Microelectronic Engineering, 2007, 84, 528-531.	1.1	2
284	A Study of Hydrogen Sensing Performance of Pt–GaN Schottky Diodes. IEEE Sensors Journal, 2006, 6, 1115-1119.	2.4	24
285	Pulsed mode operation of strained microelectromechanical resonators in air. Applied Physics Letters, 2006, 88, 253501.	1.5	38
286	Model for the thickness dependence of electron concentration in InN films. Applied Physics Letters, 2006, 89, 172109.	1.5	59
287	Tuning of Surface Properties of AlGaN/GaN Sensors for Nanodroplets and Picodroplets. IEEE Sensors Journal, 2006, 6, 881-886.	2.4	11
288	Wet chemical etching of AlN in KOH solution. Physica Status Solidi C: Current Topics in Solid State Physics, 2006, 3, 1767-1770.	0.8	22

#	Article	IF	CITATIONS
289	Growth of AlN nanowires by metal organic chemical vapour deposition. Physica Status Solidi (B): Basic Research, 2006, 243, 1476-1480.	0.7	29
290	The performance of AlGaN solar blind UV photodetectors: responsivity and decay time. Physica Status Solidi (B): Basic Research, 2006, 243, 1713-1717.	0.7	12
291	Localized donor state above the conduction band minimum in InN revealed by high pressure and temperature transport experiments. Physica Status Solidi (B): Basic Research, 2006, 243, 1537-1540.	0.7	1
292	Transition energies and Stokes shift analysis for In-rich InGaN alloys. Physica Status Solidi (B): Basic Research, 2006, 243, 1572-1576.	0.7	6
293	Relation between absorption and crystallinity of poly(3-hexylthiophene)/fullerene films for plastic solar cells. Chemical Physics Letters, 2006, 418, 347-350.	1.2	202
294	"Anomalous―pseudodielectric function of GaN: Experiment, modelling and application to the study of surface properties. Applied Surface Science, 2006, 253, 224-227.	3.1	1
295	Piezoelectric properties of polycrystalline AlN thin films for MEMS application. Sensors and Actuators A: Physical, 2006, 132, 658-663.	2.0	176
296	Pt/GaN Schottky diodes for hydrogen gas sensors. Sensors and Actuators B: Chemical, 2006, 113, 797-804.	4.0	67
297	Conduction band parameters of ZnO. Superlattices and Microstructures, 2006, 39, 299-305.	1.4	17
298	Correlation between structural and electrical properties of InN thin films prepared by molecular beam epitaxy. Superlattices and Microstructures, 2006, 40, 289-294.	1.4	9
299	Determination of strain and composition in SiC/Si and AlN/Si heterostructures by FTIR-ellipsometry. Superlattices and Microstructures, 2006, 40, 612-618.	1.4	6
300	Quantitative Auger electron spectroscopy of SiC. Vacuum, 2006, 80, 990-995.	1.6	9
301	Electronic properties of C60/InP(001) heterostructures. Journal of Physics Condensed Matter, 2006, 18, 9841-9848.	0.7	9
302	Ge-modified Si(100) substrates for the growth of 3C-SiC(100). Applied Physics Letters, 2006, 88, 211909.	1.5	25
303	Mobility edge in hydrogenated amorphous carbon. Applied Physics Letters, 2006, 88, 172114.	1.5	12
304	Impact of silicon incorporation on the formation of structural defects in AlN. Journal of Applied Physics, 2006, 100, 113531.	1.1	19
305	Micro-electromechanical systems based on 3C-SiC/Si heterostructures. Materials Science and Engineering C, 2005, 25, 804-808.	3.8	18
306	Effects of solvent and annealing on the improved performance of solar cells based on poly(3-hexylthiophene): Fullerene. Applied Physics Letters, 2005, 86, 201120.	1.5	235

#	Article	IF	CITATIONS
307	Effect of Ge incorporation on stoichiometric composition of 3C-SiC thin films grown on Si(111) substrates. Physica Status Solidi C: Current Topics in Solid State Physics, 2005, 2, 1284-1287.	0.8	4
308	Defect related absorption and emission in AlGaN solar-blind UV photodetectors. Physica Status Solidi C: Current Topics in Solid State Physics, 2005, 2, 1360-1365.	0.8	8
309	Surface conductivity of epitaxial InN. Physica Status Solidi C: Current Topics in Solid State Physics, 2005, 2, 2254-2257.	0.8	19
310	Polytype control and properties of AlN on silicon. Physica Status Solidi C: Current Topics in Solid State Physics, 2005, 2, 2199-2203.	0.8	12
311	Processing of novel SiC and group III-nitride based micro- and nanomechanical devices. Physica Status Solidi (A) Applications and Materials Science, 2005, 202, 671-676.	0.8	27
312	Effect of nanoscale surface morphology on the phase stability of 3C-AlN films on Si(111). Journal of Applied Physics, 2005, 97, 114306.	1.1	30
313	Momentum matrix element and conduction band nonparabolicity in wurtzite GaN. Applied Physics Letters, 2005, 86, 161908.	1.5	28
314	α-SiC–β-SiC heteropolytype structures on Si (111). Applied Physics Letters, 2005, 87, 201910.	1.5	7
315	Growth of three-dimensional SiC clusters on Si modelled by KMC. Computational Materials Science, 2005, 33, 375-381.	1.4	19
316	Resonant localized donor state above the conduction band minimum in InN. Applied Physics Letters, 2005, 86, 262105.	1.5	16
317	Comment on "Mie Resonances, Infrared Emission, and the Band Gap of InN― Physical Review Letters, 2004, 93, 269701.	2.9	18
318	Study of pinholes and nanotubes in AlInGaN films by cathodoluminescence and atomic force microscopy. Journal of Applied Physics, 2004, 95, 5305-5310.	1.1	12
319	Two-Dimensional Electron Gas Recombination in Undoped AlGaN/GaN Heterostructures. Japanese Journal of Applied Physics, 2004, 43, 3360-3366.	0.8	13
320	Kinetic Monte Carlo simulation of SiC nucleation on Si(111). Physica Status Solidi A, 2004, 201, 333-337.	1.7	6
321	Gap state absorption in AlGaN photoconductors and solar-blind photodetectors. Physica Status Solidi C: Current Topics in Solid State Physics, 2004, 1, 233-237.	0.8	9
322	The role of Ge predeposition temperature in the MBE epitaxy of SiC on Ssilicon. Physica Status Solidi C: Current Topics in Solid State Physics, 2004, 1, 341-346.	0.8	10
323	Lateral alignment of SiC dots on Si. Physica Status Solidi C: Current Topics in Solid State Physics, 2004, 1, 337-340.	0.8	8
324	3C-SiC:Ge alloys grown on Si (111) substrates by SSMBE. Physica Status Solidi C: Current Topics in Solid State Physics, 2004, 1, 347-350.	0.8	4

#	Article	IF	CITATIONS
325	Vertical transport in group III-nitride heterostructures and application in AlN/GaN resonant tunneling diodes. Physica Status Solidi C: Current Topics in Solid State Physics, 2004, 1, 2210-2227.	0.8	49
326	Structural and optical properties of both pure poly(3-octylthiophene) (P3OT) and P3OT/fullerene films. Thin Solid Films, 2004, 450, 97-100.	0.8	47
327	Photoreflectance studies of (Al)Ga- and N-face AlGaN/GaN heterostructures. Thin Solid Films, 2004, 450, 155-158.	0.8	19
328	Temperature-dependent electric fields in GaN Schottky diodes studied by electroreflectance. Thin Solid Films, 2004, 450, 163-166.	0.8	1
329	Self-organized SiC nanostructures on silicon. Superlattices and Microstructures, 2004, 36, 345-351.	1.4	9
330	Anisotropy of the dielectric function for wurtzite InN. Superlattices and Microstructures, 2004, 36, 591-597.	1.4	60
331	Cubic InN on -plane sapphire. Superlattices and Microstructures, 2004, 36, 487-495.	1.4	4
332	High-resolution diffuse x-ray scattering from threading dislocations in heteroepitaxial layers. Applied Physics Letters, 2004, 85, 3065-3067.	1.5	14
333	Charge Transfer at the Mn Acceptor Level in GaN. Journal of Superconductivity and Novel Magnetism, 2003, 16, 83-86.	0.5	6
334	Mid gap photoluminescence from GaN:Mn, a magnetic semiconductor. Journal of Physics and Chemistry of Solids, 2003, 64, 1685-1689.	1.9	4
335	Study of inversion domain pyramids formed during the GaN:Mg growth. Solid-State Electronics, 2003, 47, 565-568.	0.8	6
336	Energy gap and optical properties of InxGa1xN. Physica Status Solidi A, 2003, 195, 628-633.	1.7	92
337	Photoreflectance studiesof N- and Ga-face AlGaN/GaN heterostructures confininga polarisation induced 2DEG. Physica Status Solidi (B): Basic Research, 2003, 240, 380-383.	0.7	9
338	Electronics and sensors based on pyroelectric AlGaN/GaN heterostructures. Physica Status Solidi C: Current Topics in Solid State Physics, 2003, 0, 1878-1907.	0.8	65
339	Electronics and sensors based on pyroelectric AlGaN/GaN heterostructures - Part B: Sensor applications. Physica Status Solidi C: Current Topics in Solid State Physics, 2003, 0, 1908-1918.	0.8	124
340	The transition from 2D to 3D nanoclusters of silicon carbide on silicon. Technical Physics Letters, 2003, 29, 663-665.	0.2	8
341	Auger electron spectroscopy investigation of sputter induced altered layers in SiC by low energy sputter depth profiling and factor analysis. Applied Surface Science, 2003, 220, 304-312.	3.1	2
342	AlN/Diamond np-junctions. Diamond and Related Materials, 2003, 12, 1873-1876.	1.8	25

#	Article	IF	CITATIONS
343	AlN/diamond heterojunction diodes. Applied Physics Letters, 2003, 82, 290-292.	1.5	92
344	Growth of cubic InN on r-plane sapphire. Applied Physics Letters, 2003, 83, 3468-3470.	1.5	77
345	Micro-Raman study of electronic properties of inversion domains in GaN-based lateral polarity heterostructures. Journal of Applied Physics, 2003, 93, 9542-9547.	1.1	37
346	Exciton quenching in Pt/GaN Schottky diodes with Ga- and N-face polarity. Applied Physics Letters, 2003, 82, 1712-1714.	1.5	16
347	Photoelectron emission microscopy observation of inversion domain boundaries of GaN-based lateral polarity heterostructures. Journal of Applied Physics, 2003, 94, 5720-5725.	1.1	38
348	Growth and characterization of GaN:Mn epitaxial films. Journal of Applied Physics, 2003, 93, 9697-9702.	1.1	34
349	Growth of a-plane InN on r-plane sapphire with a GaN buffer by molecular-beam epitaxy. Applied Physics Letters, 2003, 83, 1136-1138.	1.5	91
350	GaN polarity domains spatially resolved by x-ray standing wave microscopy. Journal Physics D: Applied Physics, 2003, 36, A214-A216.	1.3	17
351	Sputtering of SiC with low energy He and Ar ions under grazing incidence. Radiation Effects and Defects in Solids, 2003, 158, 721-730.	0.4	2
352	Piezoresponse force microscopy for polarity imaging of GaN. Applied Physics Letters, 2002, 80, 4166-4168.	1.5	79
353	The Mn3+/2+ acceptor level in group III nitrides. Applied Physics Letters, 2002, 81, 5159-5161.	1.5	202
354	Hypersonic characterization of sound propagation velocity in AlxGa1â^'xN thin films. Journal of Applied Physics, 2002, 92, 6868-6874.	1.1	27
355	Role of defect centers in recombination processes in GaN monocrystals. Applied Physics Letters, 2002, 80, 2824-2826.	1.5	3
356	Evidence for nonlinear macroscopic polarization in III–V nitride alloy heterostructures. Applied Physics Letters, 2002, 80, 1204-1206.	1.5	746
357	Pyroelectric properties of Al(In)GaN/GaN hetero- and quantum well structures. Journal of Physics Condensed Matter, 2002, 14, 3399-3434.	0.7	864
358	Influence of GaN domain size on the electron mobility of two-dimensional electron gases in AlGaN/GaN heterostructures determined by x-ray reflectivity and diffraction. Applied Physics Letters, 2002, 80, 3521-3523.	1.5	20
359	Hydrogen response mechanism of Pt–GaN Schottky diodes. Applied Physics Letters, 2002, 80, 1222-1224.	1.5	197
360	GaN-based heterostructures for sensor applications. Diamond and Related Materials, 2002, 11, 886-891.	1.8	150

#	Article	IF	CITATIONS
361	Photoreflectance Studies of AlGaN/GaN Heterostructures Containing a Polarisation Induced 2DEG. Physica Status Solidi (B): Basic Research, 2002, 234, 713-716.	0.7	9
362	Transport Properties of 2DEGs in AlGaN/GaN Heterostructures: Spin Splitting and Occupation of Higher Subbands. Physica Status Solidi (B): Basic Research, 2002, 234, 805-809.	0.7	1
363	Thermoresistive and Piezoresistive Properties of Wurtzite N-GaN. Physica Status Solidi A, 2002, 190, 281-286.	1.7	4
364	Study of Exciton Dead Layers in GaN Schottky Diodes with N and Ga-Face Polarity. Physica Status Solidi A, 2002, 194, 480-484.	1.7	1
365	Nanotechnology for SAW devices on AlN epilayers. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2002, 93, 154-158.	1.7	34
366	Group III-nitride-based gas sensors for combustion monitoring. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2002, 93, 207-214.	1.7	79
367	Observation of ion-induced changes in the channel current of high electron mobility AlGaN/GaN transistors (HEMT). Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2002, 93, 143-146.	1.7	17
368	Gas sensitive GaN/AlGaN-heterostructures. Sensors and Actuators B: Chemical, 2002, 87, 425-430.	4.0	179
369	Electron affinity of AlxGa1â^'xN(0001) surfaces. Applied Physics Letters, 2001, 78, 2503-2505.	1.5	188
370	Residual strain effects on the two-dimensional electron gas concentration of AlGaN/GaN heterostructures. Journal of Applied Physics, 2001, 90, 4735-4740.	1.1	13
371	Photoluminescence of Ga-face AlGaN/GaN single heterostructures. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2001, 82, 200-202.	1.7	5
372	Excitonic Transitions in Homoepitaxial GaN. Physica Status Solidi (B): Basic Research, 2001, 228, 497-500.	0.7	1
373	Playing with Polarity. Physica Status Solidi (B): Basic Research, 2001, 228, 505-512.	0.7	164
374	Wetting Behaviour of GaN Surfaces with Ga- or N-Face Polarity. Physica Status Solidi (B): Basic Research, 2001, 228, 519-522.	0.7	46
375	Transport Properties of Two-Dimensional Electron Gases Induced by Spontaneous and Piezoelectric Polarisation in AlGaN/GaN Heterostructures. Physica Status Solidi (B): Basic Research, 2001, 228, 603-606.	0.7	6
376	Group-III-Nitride Based Gas Sensing Devices. Physica Status Solidi A, 2001, 185, 39-45.	1.7	137
377	High-Electron-Mobility AlGaN/GaN Transistors (HEMTs) for Fluid Monitoring Applications. Physica Status Solidi A, 2001, 185, 85-89.	1.7	116
378	Piezoresistivity of AlxGa1â^'xN layers and AlxGa1â^'xN/GaN heterostructures. Journal of Applied Physics, 2001, 90, 3383-3386.	1.1	47

#	Article	IF	CITATIONS
379	Generation–recombination noise of DX centers in AlN:Si. Applied Physics Letters, 2001, 79, 2396-2398.	1.5	20
380	Spatially resolved photoluminescence of inversion domain boundaries in GaN-based lateral polarity heterostructures. Applied Physics Letters, 2001, 79, 952-954.	1.5	58
381	Inhomogeneous incorporation of In and Al in molecular beam epitaxial AlInGaN films. Journal of Applied Physics, 2001, 90, 4868-4870.	1.1	16
382	Photoluminescence study of excitons in homoepitaxial GaN. Journal of Applied Physics, 2001, 90, 5627-5631.	1.1	43
383	Growth of quaternary AlInGaN/GaN heterostructures by plasma-induced molecular beam epitaxy. Journal of Crystal Growth, 2000, 220, 341-344.	0.7	20
384	Structural properties of AlxGa1â^'xN grown on sapphire by molecular beam epitaxy. Journal of Crystal Growth, 2000, 208, 37-41.	0.7	5
385	Influence of oxygen and methane plasma on the electrical properties of undoped AlGaN/GaN heterostructures for high power transistors. Solid-State Electronics, 2000, 44, 1361-1365.	0.8	22
386	GaN/SiC heterojunction bipolar transistors. Solid-State Electronics, 2000, 44, 259-264.	0.8	8
387	Two dimensional electron gases induced by spontaneous and piezoelectric polarization in undoped and doped AlGaN/GaN heterostructures. Journal of Applied Physics, 2000, 87, 334-344.	1.1	1,373
388	Optical characterization of Mg-doped GaN films grown by metalorganic chemical vapor phase deposition. Journal of Applied Physics, 2000, 88, 3470-3478.	1.1	23
389	Magnetic resonance investigations of defects in Ga14N and Ga15N. Journal of Applied Physics, 2000, 88, 3249-3253.	1.1	3
390	High electron mobility AlGaN/GaN heterostructure on (111) Si. Applied Physics Letters, 2000, 76, 736-738.	1.5	70
391	The polarization-induced electron gas in a heterostructure. Semiconductor Science and Technology, 2000, 15, 270-271.	1.0	51
392	GaN homoepitaxy by metalorganic chemical-vapor deposition on free-standing GaN substrates. Applied Physics Letters, 2000, 77, 1858.	1.5	78
393	DX-behavior of Si in AlN. Physical Review B, 2000, 61, R16283-R16286.	1.1	123
394	Structural and optical properties of Si-doped GaN. Physical Review B, 2000, 61, 2812-2818.	1.1	72
395	Two-dimensional electron gases in Ga-face and N-face AlGaN/GaN heterostructures grown by plasma-induced molecular beam epitaxy and metalorganic chemical vapor deposition on sapphire. Journal of Applied Physics, 2000, 87, 3375-3380.	1.1	164
396	Influence of crystal polarity on the properties of Pt/GaN Schottky diodes. Applied Physics Letters, 2000, 77, 2012-2014.	1.5	165

#	Article	IF	CITATIONS
397	Characterization of InGaN thin films using high-resolution x-ray diffraction. Applied Physics Letters, 2000, 76, 577-579.	1.5	57
398	AlGaN/GaN heterostructures on insulating AlGaN nucleation layers. Applied Physics Letters, 1999, 75, 388-390.	1.5	78
399	High-frequency AlGaN/GaN polarization-induced high electron mobility transistors grown by plasma-assisted molecular-beam epitaxy. Applied Physics Letters, 1999, 75, 3653-3655.	1.5	51
400	Compositional fluctuations in GaInN/GaN double heterostructures investigated by selectively excited photoluminescence and Raman spectroscopy. Applied Physics Letters, 1999, 74, 3981-3983.	1.5	29
401	Large Free-Standing GaN Substrates by Hydride Vapor Phase Epitaxy and Laser-Induced Liftoff. Japanese Journal of Applied Physics, 1999, 38, L217-L219.	0.8	297
402	Influence of strain and buffer layer type on In incorporation during GaInN MOVPE. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 1999, 59, 268-273.	1.7	17
403	Analysis of composition fluctuations in AlxGa1â^'xN. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 1999, 59, 182-185.	1.7	18
404	Reflectance Difference Spectroscopy Characterization of AlxGa1—xN-Compound Layers. Physica Status Solidi (B): Basic Research, 1999, 216, 215-220.	0.7	3
405	Role of Spontaneous and Piezoelectric Polarization Induced Effects in Group-III Nitride Based Heterostructures and Devices. Physica Status Solidi (B): Basic Research, 1999, 216, 381-389.	0.7	109
406	Carrier Recombination at Screw Dislocations in n-Type AlGaN Layers. Physica Status Solidi (B): Basic Research, 1999, 216, 409-414.	0.7	25
407	Polarization Induced Charge at Heterojunctions of the III-V Nitrides and Their Alloys. Physica Status Solidi (B): Basic Research, 1999, 216, 415-418.	0.7	27
408	Composition Analysis Using Elastic Recoil Detection. Physica Status Solidi (B): Basic Research, 1999, 216, 679-682.	0.7	0
409	Disorder-Activated Scattering and Two-Mode Behavior in Raman Spectra of Isotopic GaN and AlGaN. Physica Status Solidi (B): Basic Research, 1999, 216, 807-811.	0.7	16
410	Characterization of AlGaN-Schottky Diodes Grown by Plasma Induced Molecular Beam Epitaxy. Physica Status Solidi A, 1999, 176, 163-167.	1.7	5
411	MOCVD-Epitaxy on Free-Standing HVPE-GaN Substrates. Physica Status Solidi A, 1999, 176, 443-446.	1.7	11
412	Two-dimensional electron gases induced by spontaneous and piezoelectric polarization charges in N- and Ga-face AlGaN/GaN heterostructures. Journal of Applied Physics, 1999, 85, 3222-3233.	1.1	2,482
413	Dielectric function of hexagonal AlN films determined by spectroscopic ellipsometry in the vacuum-uv spectral range. Physical Review B, 1999, 59, 1845-1849.	1.1	48
414	Interface Effects on the Persistent Photoconductivity in Thin GaN and AlGaN Films. MRS Internet Journal of Nitride Semiconductor Research, 1999, 4, 520-525.	1.0	1

#	Article	IF	CITATIONS
415	Influence of buffer layers on the In-content of GaInN layers. Journal of Crystal Growth, 1998, 195, 286-290.	0.7	11
416	Defect structure of epitaxial GaN films determined by transmission electron microscopy and triple-axis X-ray diffractometry. Philosophical Magazine A: Physics of Condensed Matter, Structure, Defects and Mechanical Properties, 1998, 77, 1013-1025.	0.8	498
417	Growth and applications of Group III-nitrides. Journal Physics D: Applied Physics, 1998, 31, 2653-2710.	1.3	1,275
418	Sound velocity of AlxGa1â^'xN thin films obtained by surface acoustic-wave measurements. Applied Physics Letters, 1998, 72, 2400-2402.	1.5	307
419	Comparative determination of absolute Raman scattering efficiencies and application to GaN. Journal of Raman Spectroscopy, 1998, 29, 291-295.	1.2	15
420	Microstructural characterisation of nanocrystalline GaN prepared by detonations of gallium azides. Advanced Materials for Optics and Electronics, 1998, 8, 135-146.	0.6	12
421	Spin-Dependent Processes and Mg-Acceptors in GaN Single Quantum Well Diodes and p-Type GaN Films. Physica Status Solidi (B): Basic Research, 1998, 210, 389-393.	0.7	2
422	Nanoscale Hexagonal Gallium Nitride from Single Molecule Precursors: Microstructure and Crystallite Size Dependent Photoluminescence. Physica Status Solidi A, 1998, 165, 239-243.	1.7	6
423	Nitrogen Effusion and Self-Diffusion in Ga14N/Ga15N Isotope Heterostructures. Japanese Journal of Applied Physics, 1998, 37, 2416-2421.	0.8	41
424	Electrical and structural properties of AlGaN: A comparison with CVD diamond. Diamond and Related Materials, 1998, 7, 123-128.	1.8	5
425	Analysis of composition fluctuations on an atomic scale in Al0.25Ga0.75N by high-resolution transmission electron microscopy. Applied Physics Letters, 1998, 73, 930-932.	1.5	16
426	Detonations of Gallium Azides:Â A Simple Route to Hexagonal GaN Nanocrystals. Journal of the American Chemical Society, 1998, 120, 3512-3513.	6.6	85
427	Thermopower investigation ofn- andp-type GaN. Physical Review B, 1998, 58, 7786-7791.	1.1	47
428	Polarity determination of a GaN thin film on sapphire (0001) with x-ray standing waves. Journal of Applied Physics, 1998, 84, 1703-1705.	1.1	63
429	Time-resolved photoluminescence study of excitons in hexagonal GaN layers grown on sapphire. Physical Review B, 1998, 57, 7066-7070.	1.1	22
430	Absorption of InGaN Single Quantum Wells Determined by Photothermal Deflection Spectroscopy. Japanese Journal of Applied Physics, 1998, 37, 745-752.	0.8	43
431	Raman spectra of isotopic GaN. Physical Review B, 1997, 56, 14399-14406.	1.1	96
432	Optical constants of epitaxial AlGaN films and their temperature dependence. Journal of Applied Physics, 1997, 82, 5090-5096.	1.1	544

#	Article	IF	CITATIONS
433	Determination of the Al mole fraction and the band gap bowing of epitaxial AlxGa1â^'xN films. Applied Physics Letters, 1997, 71, 1504-1506.	1.5	290
434	Properties and applications of MBE grown AlGaN. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 1997, 50, 212-218.	1.7	52
435	Raman study of the optical phonons in AlxGa1â^'xN alloys. Solid State Communications, 1997, 104, 35-39.	0.9	65
436	Hydrogen in Gallium Nitride Grown by MOCVD. Physica Status Solidi A, 1997, 159, 105-119.	1.7	43
437	Coherent X-Ray Scattering Phenomenon in Highly Disordered Epitaxial AlN Films. Physica Status Solidi A, 1997, 162, 529-535.	1.7	20
438	Novel single source precursors for MOCVD of AlN, GaN and InN. Journal of Crystal Growth, 1997, 170, 139-143.	0.7	23
439	Growth of and AlGaN by MOCVD using triethylgallium and tritertiarybutylaluminium. Journal of Crystal Growth, 1997, 170, 335-339.	0.7	19
440	Influence of magnesium doping on the structural properties of GaN layers. Journal of Crystal Growth, 1997, 181, 197-203.	0.7	27
441	Low-Temperature OMCVD of InN Thin Films from the Novel Air-Stable Single-Molecule Precursor Azido{bis[(3-dimethylamino)propyl]}indium, (N3)In[(CH2)3NMe2]2. Chemistry of Materials, 1996, 8, 1356-1359.	3.2	36
442	Influence of substrateâ€induced biaxial compressive stress on the optical properties of thin GaN films. Applied Physics Letters, 1996, 68, 970-972.	1.5	221
443	Optical patterning of GaN films. Applied Physics Letters, 1996, 69, 1749-1751.	1.5	136
444	The first monomeric, volatile bis-azide single-source precursor to Gallium nitride thin films. Chemical Vapor Deposition, 1996, 2, 51-55.	1.4	46
445	Triazidogallium and Derivatives: New Precursors to Thin Films and Nanoparticles of GaN. Chemistry - A European Journal, 1996, 2, 1353-1358.	1.7	86
446	Sub-bandgap absorption of gallium nitride determined by Photothermal Deflection Spectroscopy. Solid State Communications, 1996, 97, 365-370.	0.9	116
447	Growth of by low-pressure MOCVD using triethylgallium and tritertbutylaluminium. Journal of Crystal Growth, 1996, 167, 1-7.	0.7	17
448	Yellow Luminescence and Hydrocarbon Contamination in MOVPE-Grown GaN. Physica Status Solidi A, 1996, 158, 587-597.	1.7	15
449	Xâ€ray diffraction study of gallium nitride grown by MOCVD. Physica Status Solidi (B): Basic Research, 1996, 193, 391-397.	0.7	16
450	Defect-related optical transitions in GaN. Physical Review B, 1996, 54, 17596-17602.	1.1	76

#	Article	IF	CITATIONS
451	Structural aspects of light emitting nc-Si prepared by plasma CVD. Journal of Luminescence, 1993, 57, 1-4.	1.5	44
452	Mechanism of Cluster Formation in a Clean Silane Discharge. Journal of the Electrochemical Society, 1993, 140, 1935-1942.	1.3	41
453	Mechanisms and rate determining steps in plasma induced high rate CVD of silicon an germanium: similarities and differences. Journal De Physique III, 1992, 2, 1431-1438.	0.3	1